

Notice of References Cited	Application/Control No. 10/670,795		Applicant(s)/Patent Under Reexamination CHEN ET AL.	
	Examiner Laura M. Schillinger		Art Unit 2813	Page 1 of 1

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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*	B	US-2004/0110375 A1	06-2004	Chen et al.	438/689
*	C	US-2004/0129674 A1	07-2004	Bease et al.	216/067
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	L	US-			
	M	US-			

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	Q	WO 2004109772 A2	12-2004	World Intellect	CHEN et al.	H01L 21/00
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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